

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Inventor..... Luan C. Tran
AssigneeMicron Technology, Inc.
Group Art Unit 2812
Examiner Geyer, Scott B.
Attorney's Docket No. MI22-2358
Title: Methods of Forming Semiconductor Constructions

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References – See Attached Form PTO/SB/08a

The attached form PTO-1449 is submitted in compliance with 37 CFR § 1.56. Copies of the cited art are included with the exception of U.S. patents and published U.S. applications (1273 Off. Gaz. Pat. Off. 55, 05 August 2003). No admission is made regarding whether all the submitted references are prior art.

Respectfully submitted,

Dated:

April 17, 2006

By:

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